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Published in Volume 6 Issue 6 , June-2019 | Date of Publication: 2019-06-01

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Advanced VLSI Technology: FinFET Technology

Published In JETIR (www.jetir.org) ISSN UGC Approved (Journal No: 63975) & 7.95 Impact Factor

Published in Volume 6 Issue 6 , June-2019 | Date of Publication: 2019-06-01

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In recognition of the publication of the paper entitled

Advanced VLSI Technology: FinFET Technology

Published In JETIR (www.jetir.org) ISSN UGC Approved (Journal No: 63975) & 7.95 Impact Factor

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